



Attorney's Docket No.: 042390P3955D

cc
870-04
Patent #
g1
Pre F

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
Andideh, Ebrahim et al.)
U.S. Serial No: 09/436,092)
Filed: November 8, 1999)
For: POLISH PAD WITH)
NON-UNIFORM GROOVE DEPTH)
TO IMPROVE WAFER POLISH RATE)
UNIFORMITY)
Examiner: McDonald, Shantese L.
Art Unit: 3723
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
NOV 25 2003
TECHNOLOGY CENTER R3700

PRELIMINARY AMENDMENT

Dear Sir:

Please enter the enclosed Preliminary Amendment and consider the following remarks prior to examination of the above-referenced case.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on November 17, 2003

Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

Teresa Edwards

Signature

November 17, 2003

Date